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Graphene transfer on highly corrugated black silicon surface

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Title of the abstract

Graphene transfer on highly corrugated black silicon surface

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Abstract text (max 200 words)

The 2D material graphene has a great promise for applications in photonics and electronics, due to its unique optical, electrical, mechanical, thermal and chemical properties. Investigation of graphene properties on rough nanotextured surfaces can give rise a new unique application of graphene. Graphene on highly corrugated surfaces can exhibit properties like suspended graphene; however, its behavior on such surfaces is not well investigated. Graphene transfer to corrugated and nanotextured surfaces has only been investigated for antireflective and mechanical properties [1-3]. We present graphene transfer methods on highly corrugated black silicon surface. We show successful transfer of graphene monolayers with different transfer techniques (dry, wet and stamp methods) on black silicon surfaces (roughness 200-300 nm) and its adhesion to corrugated surfaces. AFM and SEM images show graphene monolayer flakes in the range on 1-5 μ m on black silicon surfaces. Raman spectra confirm the presence of graphene on the black silicon samples.

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Presenter: Maksym Plakhotnyuk is a PhD student at DTU Nanotech. His current field of research is heterojunction silicon photovoltaic cell and graphene application in photovoltaics. He received his M.S.



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